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Incorporation of spatially-resolved current density measurements with photoluminescence for advanced parameter imaging of solar cells



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ABSTRACT

The spatial distribution of device performance parameters of solar cells provides important insight into their operation, including the type and magnitude of conversion losses and potential areas of improvement. In most of the procedures used to create these parameter images, a uniform (i.e., global) short-circuit current density (J_{SC}) is usually assumed. However, J_{SC} is known to vary over the surface of a solar cell, especially in polycrystalline absorber materials like multicrystalline silicon. In this work, a high speed quantum efficiency measurement rastered over the surface of a solar cell is used to obtain images of J_{SC} . These J_{SC} images are then used to calculate images of series resistance, dark saturation current density, fill factor, and conversion efficiency. Comparisons are made between the images created with a global J_{SC} and with the spatially-resolved J_{SC} . Negligible variation is observed in the series resistance and dark saturation current density images, but a drastic change is observed in the efficiency images between these two methods.

1. Introduction

Traditional solar cell characterization techniques like illuminated current-voltage $(I-V,\ J-V)$ and Suns- $V_{\rm OC}$ provide a single value (i.e., global) for the performance parameters of a solar cell, like the conversion efficiency (η) , short-circuit current density $(J_{\rm SC})$, open-circuit voltage $(V_{\rm OC})$, fill factor (FF), dark saturation current density (J_0) , and series resistance $(R_{\rm S})$. However, solar cells are large area devices that often have significant variation in these parameters over the surface of the entire device. Photoluminescence (PL) imaging is a method commonly used by the photovoltaics (PV) industry and R&D community to determine the spatial distribution of these parameters. The speed and relative simplicity of the measurement make it applicable as both an off-line and in-line metrology technique.

There have been numerous efforts to obtain spatial distributions of the performance parameters from both PL and electoluminescence (EL) signals. Fuyuki et al. developed a way of determining the spatial distribution of minority carrier diffusion length from EL [1]. PL imaging with an electrical bias have been used to obtain images of $R_{\rm S}$ [2,3]. Glatthaar et al. mathematically derived the spatial voltage distribution from the luminescence images of a silicon solar cell and two different models namely terminally connected diodes and interconnected diodes for determination of spatial maps of the physical parameters [4]. PL imaging has also been used to obtain images of efficiency [5–7] and the recombination occurring in the perimeter of the cell [8]. In all of the methods above, a global value of $J_{\rm SC}$ is assumed. It has been

demonstrated that J_{SC} is not actually uniform, but instead varies spatially across the cell. The impact of this assumption on the resulting parameter images is not clear. Several authors have suggested that it may result in substantial inaccuracies [6,7,9,10].

In this work, the impact of using a global $J_{\rm SC}$ value is investigated. We explore how this assumption influences the images obtained for efficiency, FF, J_0 , and R_s . The J_{sc} images used in this work are obtained using a high-speed external quantum efficiency (EQE) and reflectance measurement system capable of rastering over the entire surface of solar cells, a technique introduced previously [11,12]. Images of efficiency, FF, J_0 , and R_S are created using both the global J_{SC} and the spatially-resolved J_{SC} . Additionally, two different methods of determining the efficiency and FF are also compared: one relies on the PL image when the terminal voltage is set to the max-power voltage; the other relies on the generation of a J-V curve using the various parameters obtained and the Shockley diode equation. Finally, the approach presented here can be used to diagnose the root cause of defective areas within a solar cell by further analyzing the QE and reflectance images and decoupling losses based on position (i.e., front or rear side of the device) and mechanism (e.g., reflectance, parasitic absorption, recombination).

2. Methodology

The methodology presented in this work relies on the spatially-resolved EQE data as a direct measurement of the local J_{SC} , which is

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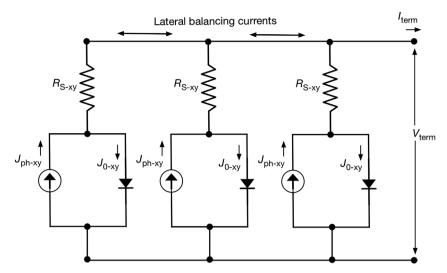


Fig. 1. Illustration of the terminal connected diode model from Ref. [17].

assumed to be equal to the local photogenerated current density $(J_{\rm ph})$. PL images are then captured under various external bias and illumination conditions to generate images of local voltage. From there, images of cell performance parameters are obtained using the methods outlined in this section.

2.1. Local photogenerated current

The local photogenerated current $J_{\text{SC-xy}}$ is obtained at each point on the solar cell using the following equation [12,13],

$$J_{SC} = e \int_{365nm}^{1200nm} \Phi_{inc}(\lambda) EQE(\lambda) d\lambda$$
 (1)

Here e, EQE and Φ_{inc} are the charge of an electron, external quantum efficiency and incident photon flux respectively. An AM1.5G solar spectrum from 365 nm to 1200 nm was considered for this calculation.

2.2. Local voltage

The well-known correlation between luminescence intensity and local voltage of a semiconductor substrate or solar cell results in the following expression relating the luminescence intensity Φ_{xy} at a position (x,y) to the local voltage at that same position [2,14]:

$$\Phi_{xy} = C_{xy} \cdot \exp\left(\frac{V_{xy}}{V_T}\right) + \Phi_{offset}$$
(2)

Here, V_{xy} and V_T are the local junction voltage and thermal voltage respectively. C_{xy} is a calibration constant independent of both the electrical bias and the illumination conditions. The offset part of luminescence intensity Φ_{offset} emerges because of the diffusion limited (i.e., voltage-independent) carrier recombination [2,15,16]. It is proportional to the illumination intensity I_L and can be expressed as

$$\Phi_{\text{offset}} = B_{xy} \cdot I_L \tag{3}$$

Here B_{xy} refers to the background luminescence signal. According to Glatthar's approximation [4], for a PL image taken at the same illumination condition I_L with the cell operating in the short-circuit condition, the resulting PL intensity becomes equal to the offset PL intensity, Φ_{offset} [17]. The background B_{xy} is calculated from this short-circuit PL image Φ_{offset} . Substituting $\Phi_{xy\text{-SC}}$ for Φ_{offset} and $I_{L\text{-SC}}$ for I_L we can write,

$$B_{xy} = \frac{\Phi_{xy-SC}}{I_{L-SC}} \tag{4}$$

The calibration constant C_{xy} is determined from an open-circuit PL image Φ_{low} , taken with a sufficiently low illumination I_{low} .

$$C_{xy} = [\Phi_{xy-low} - B_{xy} \cdot I_{low}] \cdot \exp\left(-\frac{V_{OC-low}}{V_T}\right)$$
(5)

Here, $V_{\text{oc-low}}$ is the measured open-circuit voltage at the low illumination intensity I_{low} . The key assumption is that, at a sufficiently low illumination intensity, the lateral gradient of open-circuit voltage is negligible. The intensity regime considered to be 'sufficiently low' was investigated by Hoffler [17]. They observed that for 0.19 sun illumination, the maximum voltage difference over a multicrystalline silicon cell was only 5 mV, concluding that 0.19 sun was sufficient for the calibration purpose. For this work, a conservative illumination intensity of 0.1 sun was used to capture the open-circuit PL image used in the calculation of C_{xy} . With C_{xy} and B_{xy} , the voltage distribution V_{xy} can be determined for any arbitrary PL image Φ_{xy} using the following relation,

$$V_{xy} = V_T \cdot \ln \left(\frac{\Phi_{xy} - B_{xy} \cdot I_L}{C_{xy}} \right) \tag{6}$$

2.3. Local series resistance and dark saturation current density

Images for R_{S-xy} and J_{0-xy} can be calculated using the terminal connected diode model shown in Fig. 1 [4,17]. In this model, a solar cell can be considered as a combination of parallel diodes which are connected to a common terminal through their individual series resistances. The figure comprises of three units (three parallel diodes) each having a distinct $J_{\rm ph-xy}$, R_{S-xy} , and J_{0-xy} . An infinite shunt resistance is typically assumed for analysis purposes. With $V_{\rm term}$ and n as the terminal voltage and the ideality factor of the diode, respectively, then this model results in the following equation,

$$V_{term} - V_{xy} = R_{S-xy} \left[J_{0-xy} \exp\left(\frac{V_{xy}}{nV_T}\right) - J_{ph-xy} \right]$$
(7)

For the ideality factor, a global n can be assumed as an ideal diode (n=1) [4,17] or a variable n can be used [6]. A spatially-resolved ideality factor can also be used [7,18]. In this work, we use a global n for simplicity and compare the cases where n=1 and the more realistic case where n is not equal to 1. In previous works to date, a global $J_{\rm SC}$ was assumed for quantitative PL techniques. As mentioned previously, in this work a point-by-point $J_{\rm SC-xy}$ measurement is obtained, which we use as $J_{\rm ph-xy}$ in this analysis (i.e., $J_{\rm SC-xy} = J_{\rm ph-xy}$).

 R_{S-xy} and J_{0-xy} are the two remaining unknowns in equation (7). Therefore two additional measurements with different terminal

voltages, but the same illumination condition is required.

2.4. Local efficiency using PL at $V = V_{MPP}$

To calculate the efficiency image of the cell, we need $V_{\rm MPP-xy}$ and $J_{\rm MPP-xy}$ distribution over the cell. In this work, two methods of obtaining these distributions were investigated. The first method relies on obtaining $V_{\rm MPP-xy}$ and $J_{\rm MPP-xy}$ from an additional PL image. To achieve this, an additional biased PL measurement was done at global $V_{\rm MPP}$ value of the cell at 1 sun condition (which comes from the illuminated I-V measurement). Plugging it into equation (6) provides a $V_{\rm MPP-xy}$ distribution of the cell. Then $J_{\rm MPP-xy}$ is obtained from the single diode model J-V curve [6,19].

$$J_{MPP-xy} = J_{SC-xy} - J_{0-xy} \left[e^{\frac{VMPP-xy}{n_{xy}V_T}} - 1 \right]$$
 (8)

The efficiency image can be calculated using,

$$Eff_{xy} = \frac{P_{out-xy}}{P_{in}} = \frac{V_{MPP-xy} \cdot J_{MPP-xy}}{1000Wm^{-2}}$$
(9)

Here $P_{in} = 1000 \text{ Wm}^{-2}$ is the input power density used in our experiment as the standard test condition. Noticeably the spatial distribution of the J_{SC} (i.e. J_{SC-xy}) is used in equation (9) as opposed to the previous works that used a uniform J_{SC} [19].

2.5. Local efficiency and fill factor using J-V curve fit

To provide additional insights into the impact of a spatially resolved current density, a method using locally generated J-V curves to calculate efficiency was also explored. The method is similar to the approach introduced by Breitenstein [20,21]. In their approach, dark lock-in thermography is used to generate key parameter maps including J_{01} and J_{02} and a 2-diode model is used to model each individual pixel. In this work, PL imaging is used to generate parameter maps for R_S and J_0 and EQE data is used to generate J_{SC} maps. The key difference here is the use of a single diode equation where the ideality factor can be adjusted. Since we have the local value of J_{SC} , J_0 and R_S , we can plug these into the diode equation,

$$J_{xy} = J_{SC-xy} - J_{0-xy} \left[\exp \left(\frac{V_{xy} + R_{S-xy} J_{xy}}{nV_T} \right) - 1 \right]$$
(11)

 $V_{\mathrm{MPP-xy}}$ and $J_{\mathrm{MPP-xy}}$ are obtained by finding the maximum power point of the J-V curve in equation (11). Then the local efficiency images can be calculated using equation (9).

The FF_{xy} image can be obtained from $V_{\mathrm{MPP-xy}}$ and $J_{\mathrm{MPP-xy}}$ using,

$$FF_{xy} = \frac{V_{MPP-xy} \cdot J_{MPP-xy}}{V_{OC-xy} \cdot J_{SC-xy}}$$
(12)

Here $V_{\text{OC-xy}}$ is the spatially resolved open circuit voltage distribution over the cell.

To compare the two methods of efficiency calculation, the first method requires an I-V measurement and PL measurement at 'global MPP', whereas the second method requires two additional biased PL images from which it determines the voltage and current density images at 'local MPP', other variables being the same. The second method requires more computational power as it requires an independent determination of the J-V curve for each pixel in the image.

3. Experimental details

An industrial multicrystalline Si Al-BSF solar cell was used in this work, featuring a silicon nitride (SiN_x) antireflection coating, isotropic texturing, screen-printed contacts, and an overall area of $243 \, \mathrm{cm}^2$. A multicrystalline cell was chosen due to the larger spatial variation in J_{SC} and J_0 compared to monocrystalline solar cells. A Tau Science FlashQE

system was used to measure the external quantum efficiency (EQE) and reflectance (R) over the surface of the cell. This system uses individually controlled LEDs featuring 41 distinct wavelengths (λ) between 365 nm and 1280 nm. These LEDs act as the spectrally-resolved light source and have an illuminated spot size of approximately 3 mm. The system has electronics to measure the current at each wavelength for $EQE(\lambda)$ and an integrating sphere with photodetectors to measure $R(\lambda)$. A fullspectrum $EQE(\lambda)$ and $R(\lambda)$ measurement is performed simultaneously in 1 s. This measurement system was programmed to raster over the entire surface of the solar cell to create a 97 \times 97 image of $EQE(\lambda)$ and $R(\lambda)$ [12,22]. The resulting 97 \times 97 J_{SC-xy} image was then converted into a 960 × 960 image using a linear interpolation. This interpolation was performed to achieve the same number of matrix elements in both the $J_{\rm SC-xv}$ images and the PL images. The mean $J_{\rm SC}$ (i.e., averaged over the entire surface of the cell) of the original 97×97 image and the interpolated 960 \times 960 image are equal ($J_{SC} = 32.2 \text{ mA/cm}^2$). Performing interpolation on a low-resolution image is not unusual; the linear interpolation was used previously on current density images using the LBIC method [10]. Once the J_{SC-xv} image was obtained, it was then used to calculate images of R_S , J_0 , FF, and efficiency.

Illuminated I-V measurements were performed with a BT Imaging LIS-R1 system with an 808 nm laser as the light source. First, to determine the one sun condition, global $J_{\rm SC}$ measurements were performed on the cell and the photon flux was varied until the global $J_{\rm SC}$ measured matches the spatially averaged $J_{\rm SC}$ obtained from the QE measurement. For the cell used in this study, a photon flux of $3.06 \times 10^{17} \, {\rm cm}^{-2} {\rm s}^{-1}$ and $3.06 \times 10^{16} \, {\rm cm}^{-2} {\rm s}^{-1}$ were considered as the 1 sun and 0.1 suns respectively. The global cell parameters were obtained for the cell using the 1 sun illuminated I-V curve from the LIS-R1 system (Table 1). The cell showed an overall efficiency of 15.40%, with $J_{\rm SC}=32.2 \, {\rm mA/cm}^2$ and $V_{\rm OC}=0.612 \, {\rm V}$. The global value for $R_{\rm S}$ was obtained using Suns- $V_{\rm OC}$ and illuminated IV curves following the method in Ref. [23]. The global J_0 and n were obtained via curve fitting with the software tool described in Ref. [24] which are $3.39 \times 10^{-10} \, {\rm A/cm}^2$ and $1.3 \, {\rm respectively}$.

The LIS-R1 system was also used for the PL imaging. It features an 808 nm laser, 920 nm long-pass filter, and 1-megapixel silicon CCD camera. The LIS-R1 system also features a test chuck and power supply to electrically bias solar cells during the imaging process. Two biased PL images were taken at 1 sun for the calculation of $R_{\rm S-xy}$ and $J_{\rm 0-xy}$. A PL image at 0.1 suns with the device at open-circuit (J=0) was taken and a 1 sun image with the device at short-circuit (V=0) were taken for the calculation of the background (equation (4)) and the 1 sun $V_{\rm OC-xy}$ image. An additional biased PL image was taken at 1 sun with the device held at the MPP ($V=V_{\rm MPP}$) to obtain efficiency images for one of the methods explored.

4. Results and discussion

4.1. Current and voltage images

The 97 \times 97 J_{SC} image obtained from the spatially-resolved *EQE* data and equation (1) is shown in Fig. 2(a). To be able to use both the

Table 1 Global values of the cell parameters calculated from illuminated $I\!-\!V$ and Suns- $V_{\rm OC}$ measurement.

Parameter	Value
Efficiency	0.15
$J_{ m SC}$	32.2 mA/cm ²
$V_{\rm OC}$	0.61 V
FF	0.78
$R_{\rm S}$	0.2Ω -cm ²
Ideality factor	1.3
J_0	$3.39 \times 10^{-10} \text{ A/cm}^2$

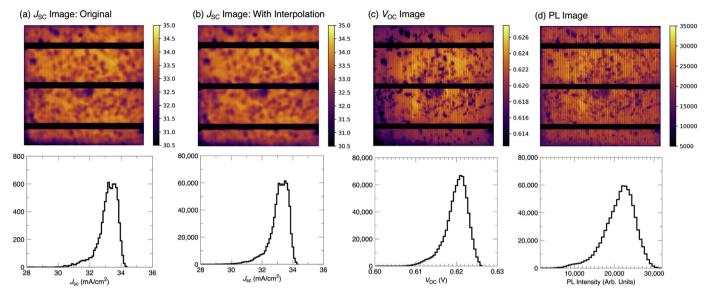


Fig. 2. Images of J_{SC} , V_{OC} , and the uncalibrated PL signal and their histograms: (a) Original J_{SC} image of size 97 \times 97 pixels; (b) interpolated J_{SC} images 960 \times 960 pixels; (c) V_{OC} image; and (c) uncalibrated PL image.

 $J_{\rm SC-xy}$ and $V_{\rm OC-xy}$ images together in the same equation for further analysis, the matrix size has to be the same for both parameters. To increase the matrix size of the $J_{\rm SC-xy}$ image, a spatial linear interpolation was used, as shown in Fig. 2(b). Both the original and interpolated $J_{\rm SC-xy}$ images and their histograms appear very similar and have equivalent spatial averages (32.2 mA/cm²). This spatial average includes the busbar regions of the cells and is equal to the global $J_{\rm SC}$ shown in Table 1. Since little information can be gained from the busbar region, this region is excluded for the analysis presented in this work. The global current density excluding the busbar regions (from global I-V curve) is 33.1 mA/cm², which is close to the mode of the $J_{\rm SC-xy}$ histogram. Noticeably, the shape of the histogram is not a symmetrical Gaussian curve but is skewed, featuring a tail on the lower end of the histogram arising from the presence of the $J_{\rm SC}$ loss mechanisms.

Fig. 2(c) shows the $V_{\rm OC}$ image and histogram of the cell calculated using the necessary PL images and equation (6). The uncalibrated PL image taken at one sun and at open-circuit is shown in Fig. 2(d). Looking at all of the images in Fig. 2, it's clear that the presence of the grain boundaries and dislocations affects the PL signal, the local voltage, and the local current. The patterns are noticeably similar for the $J_{\rm SC}$ and $V_{\rm OC}$ images, with dark regions showing up in both. This is due to the known reciprocity between luminescence and quantum efficiency of a solar cell [25]. Locations with strong PL emission also have strong QE response (i.e. higher local current and voltage). The spatial average of $V_{\rm OC}$ distribution is 0.62 V, which lies as the mode of the $V_{\rm OC}$ histogram, similar to $J_{\rm SC}$.

4.2. Series resistance and saturation current density images

Series resistance ($R_{\rm S}$) and dark saturation current density (J_0) are two important parameters of a solar cell which influence the shape of the I-V curve. The terminal connected diode model in equation (7) allows the determination of $R_{\rm S}$ and J_0 maps from two biased PL images. Fig. 3 presents four images of $R_{\rm S}$ and four images of J_0 for the same cell, where the images were created using different inputs for $J_{\rm SC}$ (i.e., global $J_{\rm SC}$ versus $J_{\rm SC,xy}$) and for the global ideality factor (ideal diode case, n=1 versus actual case, n=1.3). Unlike the $V_{\rm OC}$ and $J_{\rm SC}$ images, the $R_{\rm S}$ and J_0 images are very different from each other. The dislocations and high recombination crystal grains seen in the J_0 images are not evident in $R_{\rm S}$ images, as expected. The vertically aligned rectangular features with high resistance seen in the $R_{\rm S}$ images, denoted by dashed green rectangles in the top left image of Fig. 3(a), are the well known

sign of broken gridlines at the front of the cell [2].

Comparing the histograms for $R_{\rm S}$, the increase in the ideality factor results in a slightly higher mode of about $0.1~\Omega\text{-cm}^2$ for $R_{\rm S}$ and minor broadening of the distribution. The shape of the $R_{\rm S}$ distribution is rather symmetrical, lacking the skew observed in the distributions of $J_{\rm SC}$ and $V_{\rm OC}$ (Fig. 2). The difference between the assumption of a global $J_{\rm SC}$ and spatially-resolved $J_{\rm SC-xy}$ makes virtually no difference for both ideality factors. This suggests that the use of a global $J_{\rm SC}$ is a safe assumption when creating $R_{\rm S}$ images.

The J_0 images in Fig. 3(b) illustrate the distribution of recombination losses across the solar cell. Crystallographic defects like dislocation clusters and recombination active grain boundaries, as well as regions featuring higher concentrations of deleterious impurities (e.g., Fe) are the most common causes of the local regions with high J_0 . The shape of the J_0 distribution shown in the histograms is skewed like the $V_{\rm OC}$ and J_{SC} distribution from Fig. 2. In the case of J_0 though, the tail is on the higher end of the distribution. This makes sense as the regions with a high J_0 would be expected to have a low V_{OC} and low J_{SC} . J_0 is on the order of 10^{-12} A/cm² for the ideal diode assumption of n = 1, and as expected, it is much higher for the n = 1.3 case (10^{-10} A/cm²). There is no perceivable change in the J_0 images after incorporation of the spatially-resolved J_{SC-xy} rather than a global J_{SC} . As in the case of R_S , this suggests global J_{SC} is a safe assumption for calculating the local J_0 . In all four of the J_0 images, there is no sign of the R_S defects like the vertical rectangles caused by broken gridlines. This indicates that all of the assumptions here successfully decouple the resistive losses from the recombination losses.

4.3. Efficiency and fill factor images

Fig. 4 presents the efficiency images for both methods discussed previously. The colorbars for all images in this figure are scaled independently using the 1st percentile and 99th percentile as the minimum and maximum, respectively, excluding busbars. This is done to aid in the visual comparison. The incorporation of the spatial current density has a significant impact on the derived efficiency images. There is an increase in the contrast between the good and bad regions of the device. The histograms clearly describe this impact, as the distribution of efficiency has both shifted and widened with the incorporation of J_{SC-xy} . When an ideal diode is considered (i.e., n=1), the mean increased from 16.8% to 17.5% and when the actual global ideality factor of 1.3 is used, the mean increased from 16.4% to 17.1%. The efficiency images

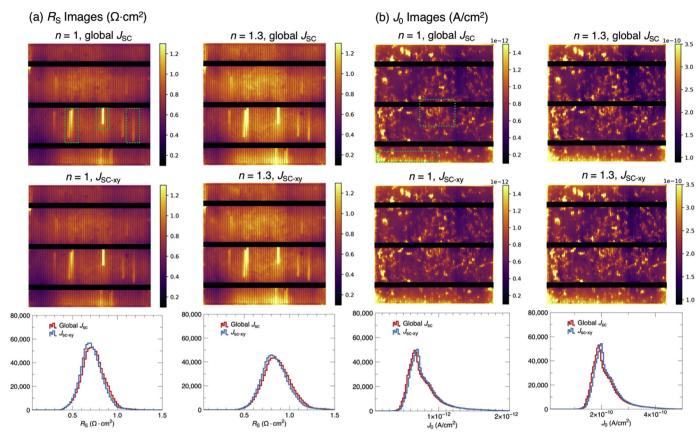


Fig. 3. (a) Series resistance images and histograms. (b) Dark saturation current density images and histograms.

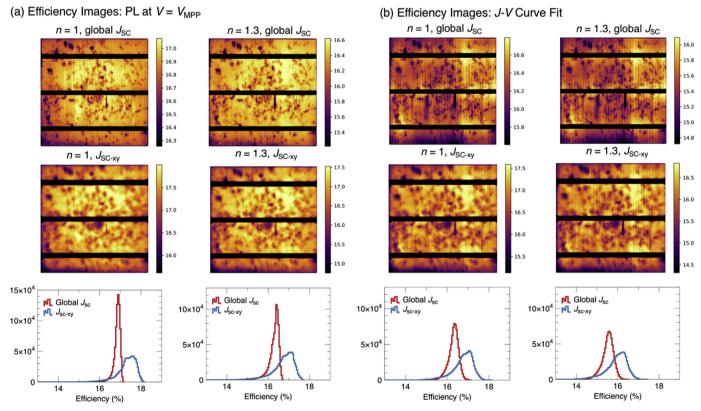


Fig. 4. Efficiency images and histograms using: (a) the PL image at a bias voltage of V = V_{MPP}; and (b) the J-V curve fitting method.

FF Images (%)

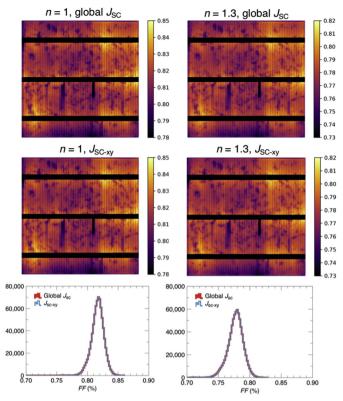


Fig. 5. Fill factor images and histograms.

are largely influenced by recombination losses including the sites associated with dislocations and grain boundaries. It is worth mentioning here that we did not separate the edge recombination from the total recombinationin in the device for simplicity; edge recombination can lead to reduced efficiency value of a cell [8]. Series resistance related defects appear to have only a minor influence on the local efficiency, although these regions are more pronounced in the J-V curve fit method. For both methods, the resulting efficiency images including $J_{\text{SC-xy}}$ have remarkably similar distributions.

Although it is not directly related to optoelectronic properties, the fill factor is useful in performance evaluation of a solar cell. It dictates the shape of the I-V curve. A spatial map of fill factor could account for the relative difference of performance over the surface of a cell. The fill factor images in Fig. 5 are affected by both the series resistance and the dark saturation current density. Increasing the ideality factor from 1 to 1.3 lead to a decrease in the mean fill factor from 0.82 to 0.78. For both cases, incorporation of spatial current density does not change the fill factor at all. Fill factor is a ratio between the maximum power of the I-V curve and the maximum power attainable if there was no loss present.

4.4. Loss analysis using quantum efficiency

The images of EQE and R used to create the J_{SC-xy} input parameter in this work can also be used for loss analysis of the solar cell. This is particularly useful when trying to attribute optical and recombination losses to a particular layer or interface within the device. The details of this approach were described in prior work [12,26], but here we provide a brief description for the sake of information. The internal quantum efficiency (IQE) at a point over the cell can be calculated from the measured value of EQE and R at that point,

$$IQE(\lambda) = \frac{EQE(\lambda)}{1 - R - f_{eff}}$$
(13)

Here $f_{\rm eff}$ is the effective optical shaded fraction within the measurement light-spot, occurring due to the presence of the gridlines. Now according to the model proposed by Fischer et al., IQE can be expressed in terms of the effective diffusion length (L_{eff}), absorption length of silicon (L_{o}) and an scaling factor (k) as following,

$$IQE(\lambda) = \frac{1}{k} \exp\left(-\frac{W_d}{L_a(\lambda)}\right) \frac{1}{1 + \frac{L_a(\lambda)}{L_{eff}}}$$
(14)

Here W_d is the thickness of a hypothetical dead layer which accounts for the parts of the emitter which do not contribute to the photogenerated current because of recombination occurring. L_a is used from the literature and IQE from equation (13). Running a simple iterative process starting with the reasonable guess for the rest of the parameters provides the value of k, L_{eff} and W_d . Here, the slope and intercept of the $\ln\left(IQE\cdot\left(1+\frac{L_a}{L_{eff}}\right)\right)$ vs. $\frac{1}{L_a}$ plot at any wavelength provides the values for W_d and k respectively at that wavelength. These values are then used for plotting $\frac{1}{IQE} \exp\left(\frac{W_d}{L_a}\right)$ vs. La graph which then provides the values for L_{eff} and k. This iterative process continues until it converges to the actual values of k, L_{eff} and W_d .

Once the L_{eff} and W_d and values become available, they can be used for calculating the losses in emitter. The total loss in emitter can be divided into two discrete wavelength regimes: (I) 365 nm - 500 nm, where the dead layer approximation is inadequate and (II) 500 nm - 1280 nm, where the dead layer approximation is reasonable. With this, the IQE loss in emitter can be expressed as,

$$IQE_{loss,emi,I} = 1 - IQE(\lambda) \cdot \left(1 - \frac{L_a(\lambda)}{L_{eff}}\right)$$
 (15a)

$$IQE_{loss,emi,II} = 1 - \exp\left(-\frac{W_d}{L_a(\lambda)}\right)$$
(15b)

Now the total current loss in emitter (J_{loss-e}) can be calculated from the these IQE loss values. The rest of the parasitic loss is then attributed to the loss in the base (J_{loss-e}) .

Fig. 6 shows results of such analysis including maps of the L_{eff} , current loss in the emitter (J_{loss-e}) and current loss in the base (J_{loss-h}) and compares this with what is seen in the PL image. Regions associated with a high density of dislocations are highlighted in green and are associated with lower effective diffusion lengths and higher current loss in the base of the device. The same regions also showed high magnitude in the J_0 image (Fig. 3) and low magnitude in the J_{SC} (Fig. 2(a)) and V_{OC} (Fig. 2(c)) images. The current loss in the base is significantly larger than the current loss in the emitter. Although the impact is minor, the spatial variation of the dopant concentration in the emitter, with a higher dopant concentration near the edges of the device, can be identified in Fig. 6(b). This pattern is not present in any of the parameter maps derived from PL images alone. The combination of both spatially resolved PL and QE provides a complete picture of where the losses are occurring within the device and the impact they have on overall performance.

5. Conclusion

In this work, a method of using the local photogenerated current as an input to create images of solar cell parameters (e.g., efficiency) is presented. Various methods of extracting cell parameters images using photoluminescence were carried out on the same multicrystalline silicon Al-BSF solar cell with an emphasis on any changes that occur when assuming a uniform global $J_{\rm SC}$ across the entire cell versus a local $J_{\rm SC-xy}$ obtained using spatially-resolved quantum efficiency measurements. The application of a local $J_{\rm SC-xy}$ had a negligible influence on the extraction of $R_{\rm S}$, $J_{\rm O}$, and fill factor, indicating the use of a global $J_{\rm SC}$ is likely a valid assumption for these parameters. In stark contrast, the use

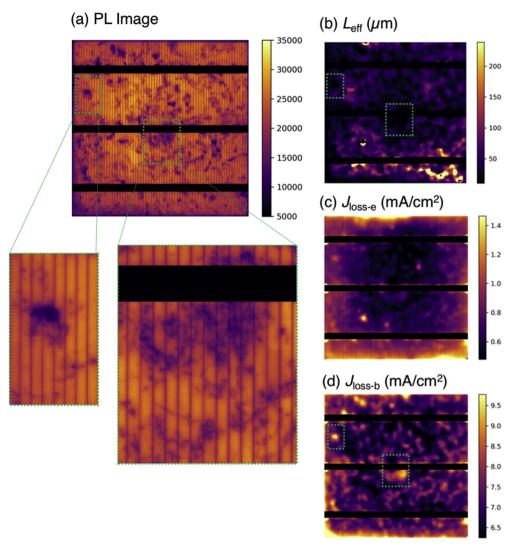


Fig. 6. The results of the current loss analysis: (a) PL image; (b) effective diffusion length; (c) emitter los (d) and bulk and rear loss due to recombination and parasitic optical absorption.

of a local $J_{\rm SC-xy}$ had a large influence on the extraction of local cell efficiency, increasing the mode of the local efficiency histogram and broadening the distribution. Additionally, this method has the benefit of using the spatially-resolved quantum efficiency and reflectance data for loss analysis when evaluating areas with particular poor performance (e.g., high J_0 , low efficiency). This can be used to identify the root cause of manufacturing defects and to evaluate how spatial variance in parameters like the effective diffusion length, current loss in the emitter, current loss in the base, front surface reflectance losses, and escape reflectance.

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Appendix A. Supplementary data

Supplementary data to this article can be found online at https://doi.org/10.1016/j.solmat.2019.04.012.

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